



AMENDMENT TRANSMITTAL LETTER				Docket No. TESSERA 3.0-081 DIV CONT	
Application No. 09/638,079	Filing Date August 14, 2000	Examiner P. Dang	Group Art Unit 2818		
Applicant(s): Thomas H. DiStefano and Joseph Fjelstad					
Invention: METHODS FOR PROVIDING VOID-FREE LAYERS FOR SEMICONDUCTOR ASSEMBLIES					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	40	- 40 =	0	x 18.00	0.00
Independent Claims	8	- 8 =	0	x 80.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. <u>12-1095</u> in the amount of \$ _____ A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge and credit Deposit Account No. <u>12-1095</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Kimberly V. Perry Attorney Reg. No.: 43,612				Dated: <u>September 14, 2001</u>	
LERNER, DAVID, LITTENBERG, KRUMHOLZ & MENTLIK, LLP 600 South Avenue West Westfield, New Jersey 07090 (908) 518-6361					

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
DiStefano et al. :

Application No. 09/638,079 :

Filed: August 14, 2000 :

For: METHODS FOR PROVIDING :
VOID FREE LAYERS FOR :
SEMICONDUCTOR ASSEMBLIES :
X

Commissioner for Patents
Washington, D.C. 20231

Group Art Unit: 2818

Examiner: P. Dang

Date: September 14, 2001

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AMENDMENT

Sir:

In response to the Official Action mailed
June 18, 2001, Applicants submit the following remarks.

I hereby certify that this correspondence is being
deposited with the United States Postal Service with sufficient
postage as First Class mail in an envelope addressed to
Commissioner for Patents, Washington, D.C. 20231 on September
14, 2001.


(Signature)

Kimberly V. Perry

Typed or Printed Name of Person Signing Certificate